VLSI Devices Lecture 11

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Drain current

• Electron current density at a point
$$(x, y)$$

$$J_n(x, y) = -q\mu_n n(x, y) \frac{dV}{dy}$$

 $\mathbf{J}_n = -q\mu_n n \nabla \phi_n$

Taur, Eq. (3.5)

- (It includes both the drift and diffusion currents.)

– When integrated from
$$x=0$$
 to x_i , (and from $z=0$ to W)
$$I_d(y) = qW \int_0^{x_i} \mu_n n(x,y) \frac{dV}{dy} dx \qquad \text{Taur, Eq. (3.6)}$$

Sign change due to convention of terminal current

z-directional width

Further simplification

• Electron current density at a point (x, y)

$$I_d(y) = qW \int_0^{x_i} \mu_n n(x, y) \frac{dV}{dy} dx = -\mu_{eff} W \frac{dV}{dy} \left(-q \int_0^{x_i} n(x, y) dx \right)$$

$$= -\mu_{eff} W \frac{dV}{dy} Q_i(y)$$
Taur, Eq. (3.8)

- We introduce an effective mobility, μ_{eff} .
- Since V is a function of y only, V is interchangeable with y.

$$Q_i(y) = Q_i(V)$$

-Then,

$$I_d(y)dy = \mu_{eff}W[-Q_i(V)]dV$$

$I_d(y)$ is actually a constant.

• When integrated from y=0 to L, (from V=0 to V_{ds})

$$I_d = \mu_{eff} \frac{W}{L} \int_0^{V_{ds}} [-Q_i(V)] dV$$
 Taur, Eq. (3.10)

-Then, how can we find $Q_i(V)$? (We must perform the x-directional integration.)

egration.)
$$Q_i = -q \int_0^{x_i} n(x,y) dx = -q \int_{\phi_s}^{\delta} \frac{dx}{n(\phi,V)} \frac{dx}{d\phi} d\phi \qquad \text{but not zero.}$$

$$= -q \int_{\delta}^{\phi_s} \frac{\left(n_i^2/N_a\right) \exp\left(\frac{q}{k_B T}(\phi - V)\right)}{E_x(\phi,V)} d\phi \qquad \text{Taur, Eq. (3.12)}$$

Pao-Sah double integral

• Finally, the expression for I_d reads

$$I_{d} = q\mu_{eff} \frac{W}{L} \int_{0}^{V_{ds}} \left[\int_{\delta}^{\phi_{s}} \frac{\left(n_{i}^{2}/N_{a}\right) \exp\left(\frac{q}{k_{B}T}(\phi - V)\right)}{E_{x}(\phi, V)} d\phi \right] dV$$

Taur, Eq. (3.13)

- It is the Pao-Sah double integral.
- Rigorous within the GCA, but it is difficult to evaluate.

How can we determine ϕ_s ?

• For given
$$V_{gs}$$
 and V , we can solve the MOS equation.
$$V_{gs} = V_{fb} + \phi_s - \frac{Q_s}{C_{ox}}$$

$$= V_{fb} + \phi_s + \frac{\sqrt{2\epsilon_{si}k_BTN_a}}{C_{ox}} \left[\frac{q\phi_s}{k_BT} + \frac{n_i^2}{N_a^2} \exp\left(\frac{q}{k_BT}(\phi_s - V)\right) \right]^{1/2}$$
 Taur, Eq. (3.14)

Only two important

terms are kept.

– We can numerically solve the above equation to obtain ϕ_s . (Newton method)

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Write a code. (1) These are optional.

- Calculate I_d at V_{gs} = 1.1 V and V_{ds} = 0.5 V.
 - We follow the Riemann sum approach.
 - -Then, let's introduce 101 V values, from 0 V to 0.5 V. (5 my spacing)

$$I_{d} \approx q \mu_{eff} \frac{W}{L} \sum_{j=0}^{100} \left[\int_{\delta}^{\phi_{S}} \frac{(n_{i}^{2}/N_{a}) \exp\left(\frac{q}{k_{B}T}(\phi - V_{j})\right)}{E_{x}(\phi, V_{j})} d\phi \right] \Delta V_{j}$$

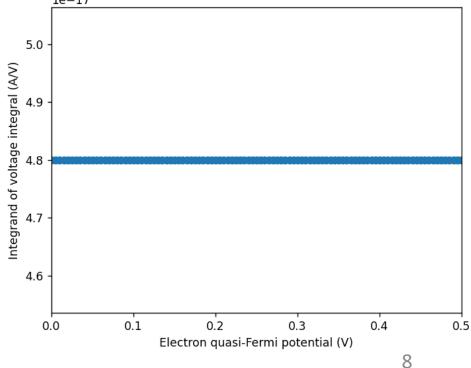
- When j = 0 or j = 100, ΔV_j is 2.5 mV.
- Otherwise, ΔV_i is 5 mV.
- Use $q\mu_{eff}\frac{W}{L}$ = 4.8 X 10⁻¹⁷ A cm² V⁻¹. (A rough estimation for n_i , 10¹⁰ cm⁻³, is used.)

Write a code. (2)

Test the integral.

- Assume that
$$\left[\int_{\delta}^{\phi_{S}} \frac{(n_{i}^{2}/N_{a}) \exp\left(\frac{q}{k_{B}T}(\phi - V_{j})\right)}{E_{x}(\phi, V_{j})} d\phi \right] = 1 \text{ cm}^{-2}$$

- -Then, the integral shoud be 2.4 X 10⁻¹⁷ A.
- Check your code.



Write a code. (3)

• Now, we must perform the ϕ -integral.

$$\int_{\delta}^{\phi_{S}} \frac{\left(n_{i}^{2}/N_{a}\right) \exp\left(\frac{q}{k_{B}T}(\phi - V_{j})\right)}{E_{x}(\phi, V_{i})} d\phi$$

- We must know two bounds, δ and ϕ_s .
- We can set a small value for δ . (It doesn't matter. $\delta = V_j + 1$ mV, for example)
- However, ϕ_s is not easy to evaluate. (We must adopt the Newton method.)
- Instead, an approximate value for ϕ_s will be used.

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Write a code. (4)

• The ϕ -integral is approximated as

$$\int_{\delta}^{\phi_{S}} \frac{\left(n_{i}^{2}/N_{a}\right) \exp\left(\frac{q}{k_{B}T}(\phi - V_{j})\right)}{E_{x}(\phi, V_{j})} d\phi$$

$$\approx \sum_{k=1}^{k_{S}} \frac{\left(n_{i}^{2}/N_{a}\right) \exp\left(\frac{q}{k_{B}T}(k \text{ mV})\right)}{E_{x}(V_{j} + k \text{ mV}, V_{j})} \times 1 \text{mV}$$

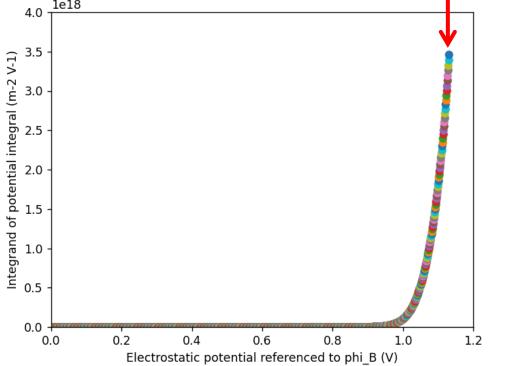
- Here, $V_j + k_s$ mV is a good approximation of ϕ_s .
- Parameters: V_{fb} is -1.08 V. C_{ox} is 2.88X10⁻⁶ F/cm². (t_{ox} is 1.2 nm.) N_a is 10^{18} cm⁻³.

Write a code. (5)

• A specific example, when V_i is 0 V.

 $V = \frac{(n_i^2/N_a) \exp\left(\frac{q}{k_B T}(\phi - V_j)\right)}{E_{\chi}(\phi, V_j)}$ as a function of ϕ . Draw

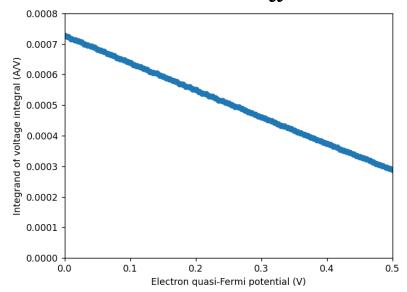
-Stopped when the MOS equation changes its sign. (Approximate ϕ_s) - Integrated electron density is about 1.517 X 10¹³ cm⁻².

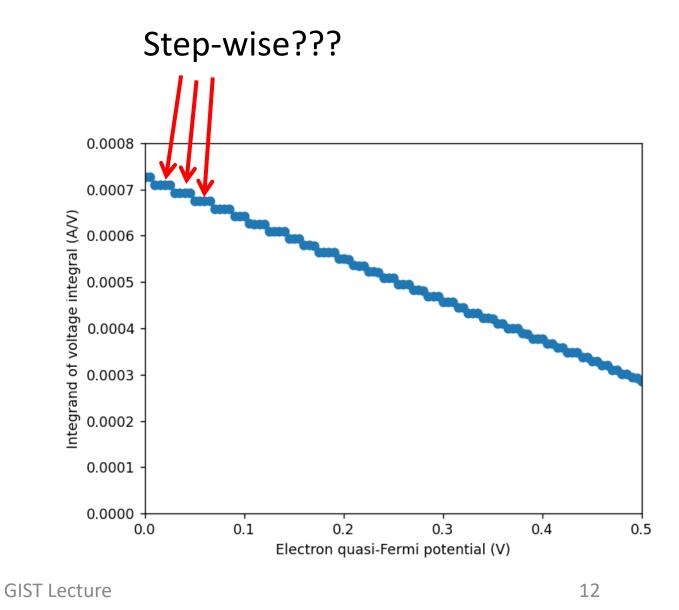


Approximate ϕ_{ς}

Write a code. (6)

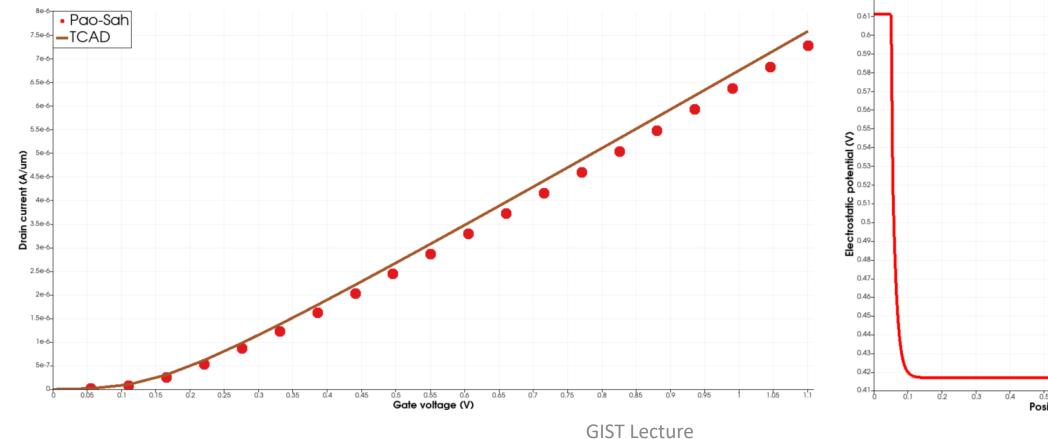
- Integrand of the V-integral
 - By integrating it, we can find I_d = 252.8 μ A.
 - Instead of 1 mV, we can try an even finer ϕ spacing.
 - With 0.2 mV, I_d = 252.9 μ A.

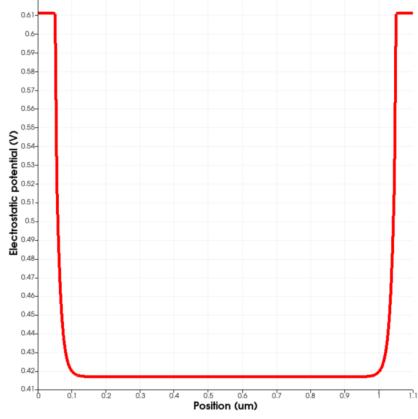




Verify the result.

- TCAD simulation result (at V_{ds} = 0.01 V)
 - -They are similar, but not perfectly matched. Why?





Charge-sheet model

- Simpler model with further approximations
 - Consider the previous method to calculate Q_i :

$$Q_{i} = -q \int_{\delta}^{\phi_{S}} \frac{\left(n_{i}^{2}/N_{a}\right) \exp\left(\frac{q}{k_{B}T}(\phi - V)\right)}{E_{x}(\phi, V)} d\phi$$

-A simpler way? Instead, Q_d is approximated as

$$Q_d = -qN_aW_d = -\sqrt{2\epsilon_{si}qN_a\phi_s}$$

Taur, Eq. (3.15)

-Then, Q_i can be approximated as

$$Q_i = Q_s - Q_d = -C_{ox}(V_{gs} - V_{fb} - \phi_s) + \sqrt{2\epsilon_{si}qN_a\phi_s}$$

Taur, Eq. (3.16)

(Of course, it is not exact.)

Thank you!